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1732

DOCKET NO.: 4029

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
IN THE MATTER OF THE APPLICATION FOR PATENT

OF: Michio OSADA et al.

Art Unit: 1732

SERIAL NO.: 09/705,237

FILED: November 2, 2000

FOR: Die Used for Resin-Sealing and
Molding an Electronic Component

TC 1700 MAIL ROOM

NOV 15 2002

RECEIVED

ASSISTANT COMMISSIONER FOR PATENTS

WASHINGTON, D. C. 20231

November 4, 2002

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

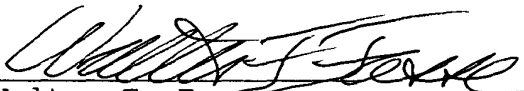
- 1) Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98 applicants enclose a Form PTO-1449 and a copy of the reference listed thereon. A copy of a Korean Office Action and a translation thereof issued in a counterpart Korean Application on August 26, 2002 is also enclosed.
- 2) This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits, to the best knowledge of the undersigned attorney.
- 3) The undersigned attorney hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement, as seen from the Korean Office Action issue date of August 26, 2002.

- 4) The enclosed English translation of the Korean Office Action issued on August 26, 2002 in the counterpart Korean Application is being submitted to show why the reference is being cited as possibly material herein. The assertions and discussion of the reference set forth by the Korean Examiner are not adopted or conceded as correct by the applicant, but are submitted for the U. S. Examiner's consideration in evaluating this reference.
- 5) Reference AA is accompanied by an English language Abstract. Therefore no further discussion of the reference is required.
- 6) Applicant respectfully requests that the Examiner consider all references of record, return an initialled copy of the enclosed Form PTO-1449 and ensure that all references of record are printed on any patent issuing from this application.

Respectfully submitted,

Michio OSADA et al.
Applicant

WFF:ar/4029
Enclosure: postcard,
Form PTO-1449,
1 reference, Korean
Office Action and English
translation thereof

By 
Walter F. Fasse
Patent Attorney
Reg. No.: 36132
Tel. No.: 207-862-4671
Fax. No.: 207-862-4681
P.O. Box 726
Hampden, ME 04444-0726

CERTIFICATE OF MAILING:

I hereby certify that this correspondence with all indicated enclosures is being deposited with the U. S. Postal Service with sufficient postage as first-class mail, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D. C. 20231, on the date indicated below.

Anita Morse - November 4, 2002
Name: Anita Morse - November 4, 2002